

196743US-2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

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TC 1700

IN RE APPLICATION OF:

TSUTOMU HIROKI

:

: EXAMINER: MOORE, KARLA A.

SERIAL NO: 09/655,304

:

FILED: SEPTEMBER 5, 2000

: GROUP ART UNIT: 1763

FOR: TRANSFER APPARATUS AND :
ACCOMMODATING APPARATUS
FOR SEMICONDUCTOR PROCESS,
AND SEMICONDUCTOR
PROCESSING SYSTEM

#7A
5/22/03
MW

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Official Action dated January 17, 2003, please amend the above-identified application as follows:

IN THE CLAIMS

Please amend the claims as shown in the marked-up copy.¹

1. (Amended) A transfer apparatus for a semiconductor process, comprising:

A₁ an articulated arm unit attached to a support base to be stretchable/retractable within a horizontal plane, the articulated arm unit having a distal end arm which reciprocates in a first direction when the articulated arm unit stretches and retracts;

¹The marked-up copy attached herewith shows using underlining and bracketing the changes made in the claims.